

ICC-273
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: :
Hideki Ueno, et al :
Application No.: 10/656,119 :
Filed: September 8, 2003 :
For: SILICONE RESIN COMPOSITION) Examiner: M. S. Zimmer
: Group Art Unit: 1712
: Confirmation No.: 7055
: June 20, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST TO CORRECT INVENTORSHIP
UNDER 37 C.F.R. § 1.48(a)(1)

Sir:

This Request to Correct Inventorship is filed to correct the omission of inventors of that which is defined by the subject patent application. The omitted inventors, Ikuo Takahasi and Hideji Tomita, have executed a declaration and a statement that their omission was through error and without deceptive intent (both enclosed).

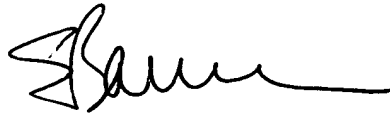
Applicants request that the U.S. Patent Trademark Office change the official records for this application, and issue a corrected official Filing Receipt, noting the added inventors.

The Commissioner is hereby expressly authorized to charge the fee required under 37 C.F.R. § 1.17(i) of \$130.00 to

Deposit Account No. 12-2135, and to charge any additional fees required by this Request or credit any overpayment thereof to that deposit account. A duplicate of this Request is attached for that purpose.

Applicants' undersigned attorney may be reached by telephone at (860) 571-5001 or by facsimile at (860) 571-5028. All correspondence should continue to be directed to the address given below.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'Bauman', written over a horizontal line.

Steven C. Bauman
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